

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)
Shinji MAEKAWA et al.	) Group Art Unit: 2812
Application No. 10/575,492	) Examiner: Stanetta D. Isaac
Filed: April 12, 2006	) Confirmation No. 3788
For: METHOD FOR FORMING WIRING,	)
METHOD FOR MANUFACTURING	)
THIN FILM TRANSISTOR AND	)
DROPLET DISCHARGE METHOD	) Date: April 7, 2008

**AMENDMENT**

Mail Stop AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed January 8, 2008, please amend the above identified application as follows: